

PTO/SB/08A (04-03)

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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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**Complete if Known**

Application Number	10/616147
Filing Date	07-08-2003
First Named Inventor	Klaus KUNZE
Art Unit	
Examiner Name	
Attorney Docket Number	KOV-004

Sheet 1 of 3

**U. S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
	AA	US- 6,268,041	07-31-2001	Goldstein	
	AB	US- 6,013,872	01-11-2000	Woditsch et al.	
	AC	US- 4,992,520	02-12-1991	Zeigler	
	AD	US- 4,868,014	09-19-1989	Kanai et al.	
	AE	US- 4,851,297	07-25-1989	Allen et al.	
	AF	US- 4,841,083	06-20-1989	Nagai et al.	
	AG	US- 4,835,005	05-30-1989	Hirooka et al.	
	AH	US- 4,830,890	05-16-1989	Kanai	
	AI	US- 4,818,560	04-04-1989	Ishihara et al.	
	AJ	US- 4,759,947	07-26-1988	Ishihara et al.	
	AK	US- 4,726,963	02-23-1988	Ishihara et al.	
	AL	US- 4,704,444	11-03-1987	Brown-Wensley et al.	
	AM	US- 4,683,146	07-28-1987	Hirai et al.	
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	AO	US- 4,569,953	02-11-1986	West et al.	
	AP	US- 4,537,942	08-27-1985	Brown-Wensley et al.	
	AQ	US- 4,407,858	10-04-1983	Hanke et al.	
	AR	US- 4,330,358	05-18-1982	Grabmaier et al.	
	AS	US- 4,276,424	06-30-1981	Peterson, Jr. et al.	

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>3</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				
	AT	EP 1 113 502 A1 ✓	07-04-2001	Seiko Epson Corporation		
	AU	EP 1 087 433 A1 ✓	03-28-2001	JSR Corporation		
	AV	EP 1 087 428 A1 ✓	03-28-2001	Seiko Epson Corporation		
	AW	EP 1 085 579 A1 ✓	03-21-2001	Seiko Epson Corporation		
	AX	EP 1 085 560 A1 ✓	03-21-2001	Seiko Epson Corporation		
	AY	WO 00/59014 ✓	10-05-2000	Seiko Epson Corporation		

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First Named Inventor	Klaus KUNZE
Art Unit	
Examiner Name	
Attorney Docket Number	KOV-004

Sheet	2	of	3
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## U. S. PATENT DOCUMENTS

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## FOREIGN PATENT DOCUMENTS

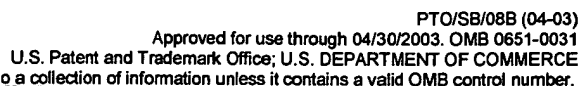
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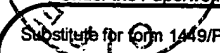


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<div style="text-align: center;">  <p><b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b></p> <p><i>(Use as many sheets as necessary)</i></p> </div>				<b>Complete if Known</b>	
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				Examiner Name	
Sheet	3	of	3	Attorney Docket Number	KOV-004

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
/	CA	Yukio NISHIMURA et al.; Patent Abstracts of Japan, Publication No. 60242612 A, Application No. 59098420; Depositing Film Forming Method; 12-02-1985	
/	CB	Kotaro YANO et al.; Patent Abstracts of Japan, Publication No. 07267621 A, Application No. 06054004; Formation of Silicon Membrane; 10-17-1995	
/	CC	Tsutomu TAKADERA et al.; Patent Abstracts of Japan, Publication No. 2000031066 A, Application No. 10195985; Method for Forming Silicon Film and Manufacture of Solar Battery; 01-28-2000	
/	CD	Keiichi FUKUYAMA et al.; Patent Abstracts of Japan, Publication No. 2000007317 A, Application No. 10173683; Formation of Silicon Film; 01-11-2000	
/	CE	Yutaka KITSUNO et al.; Patent Abstracts of Japan, Publication No. 09045922 A, Application No. 07192044; Method for Forming Poly Crystal Silicon Film; 02-14-1997	

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